Electronic Patent Application Fee Transmittal							
Application Number:							
Filing Date:							
Title of Invention:	High Purity Hafnium, Target and Thin Film Comprising said High Purity Hafnium, and Method for Producing High Purity Hafnium						
First Named Inventor:	Yuichiro Shindo						
Filer:	William Bak						
Attorney Docket Number:	OGOSH53USA						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
National Stage Fee		1631	1	300	300		
Natl Stage Search Fee - Report provided		1642	1	400	400		
National Stage Exam - all other cases		1633	1	200	200		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Miscellaneous:				
	Tota	al in USI	) (\$)	900